



MAIL STOP AMENDMENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: F.M. Schellenberg et al. Attorney Docket No.: MEGC122529
Application No.: 10/811,418 Art Unit: 2825 / Confirmation No.: 2647
Filed: March 26, 2004 Examiner: Binh C. Tat
Title: CREATING PHOTOLITHOGRAPHIC MASKS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

February 15, 2006

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. X Pursuant to 37 C.F.R. § 1.97(c), this Supplemental Information Disclosure Statement is being filed after the period set forth in 37 C.F.R. § 1.97(b) but before the mailing date of a final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution, and is accompanied by:
 - a. X the submission fee set forth in 37 C.F.R. § 1.17(p). Check No. 168679 in the amount of \$180 is enclosed.

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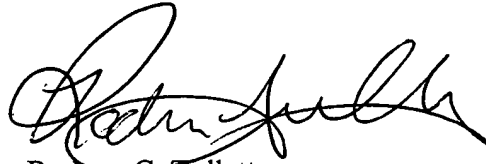
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2. X The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

CHRISTENSEN O'CONNOR
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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

Date:

February 15, 2006



RCT:jh

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SUPPLEMENTAL INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL
TO THE PROSECUTION OF THE SUBJECT APPLICATION

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U.S. PATENT DOCUMENTS

| *Examiner Initials | Cite No. | Document No. | Kind Code | Date (mm/dd/yyyy) | Name |
|-----------------------|-------------|--------------|--------------|----------------------|---------------|
| _____ | U16 | 6,416,907 | B1 | 07/09/2002 | Winder et al. |
| _____ | U17 | 6,620,561 | B2 | 09/16/2003 | Winder et al. |

FOREIGN PATENT DOCUMENTS

| *Examiner Initial | Cite No. | Document No. | Kind Code | Publication Date (mm/dd/yyyy) | Country | English Abstract Provided | Translation Provided |
|----------------------|-------------|--------------|--------------|----------------------------------|---------|---------------------------------|-------------------------|
| None | | | | | | | |

OTHER INFORMATION

(Including Author, Title, Date, Pertinent Pages, Etc.)

| *Examiner Initial | Cite No. |
|----------------------|-------------|
| None | |

| Examiner | Date Considered |
|----------|-----------------|
| _____ | _____ |

*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RCT:jh

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